



RECEIVED
 CENTRAL FAX CENTER

MAY 03 2006

May 3, 2006

Time: 5/1/06 8:11 PM
 (Santa Clara, California)

To: Commissioner for Patents
 Attn: New Central Fax
 Patent Examining Corps
 Facsimile Center
 P.O.Box 1450
 Alexandria, VA 22313-1450

From: Pamela J. Squyres
 Attorney Docket: MA-100-I
 Phone: 408-869-2921

FAX NUMBER 571-273-8300

| | |
|--|-------------------------------|
| Re: Patent Application of: S. B. Herner | Examiner: Bret P. Chen |
| Serial No.: 10/769,047 | Group Art Unit: 1762 |
| Filed: January 30, 2004 | Attorney Docket No.: MA-100-I |
| Title: Low Temperature, Low-Resistivity Heavily Doped P-Type Polysilicon Deposition | |

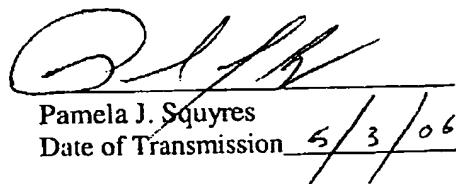
Document(s) Transmitted:

- Response to Non-Final Office Action (14 pages)
- Application Data Sheet (4 pages)

Total pages of this transmission, including the cover letter: 19

If you do not receive all of the pages described above, please telephone us at 408-869-2921 or fax us at 408-969-4849.

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on the date shown below.


 Pamela J. Squyres
 Date of Transmission 5/3/06